

Building College-University Partnerships for Nanotechnology Workforce Development

## **Wave-Based Characterization**

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School of Engineering

Grand Valley State University







#### **Classroom Resources**











WWW.PHDCOMICS.COM

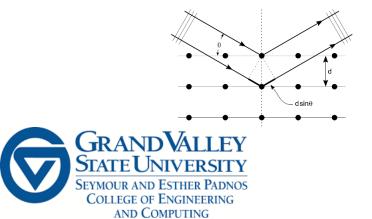


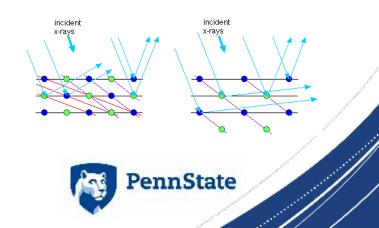




## • What is it and Why is it important?

- A very frequently used tool in order to determine
  - Crystal structure
  - Crystal size
  - Internal stress
  - Composition
- Elastic scattering (Bragg diffraction) of the X-rays from the examined materials are collected. Reflected X-rays will interfere and possess information about the crystallography.







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- Examining Interference from two sources separated by a distance
  - Phet University of Colorado Boulder offers excellent illustrative tools to explain how the local positioning of the light sources can have an effect on the collected far-field diffraction patterns on a screen. This example can be linked to the reflection from the periodic atomic configurations: crystals. <u>Wave Interference</u> (colorado.edu)





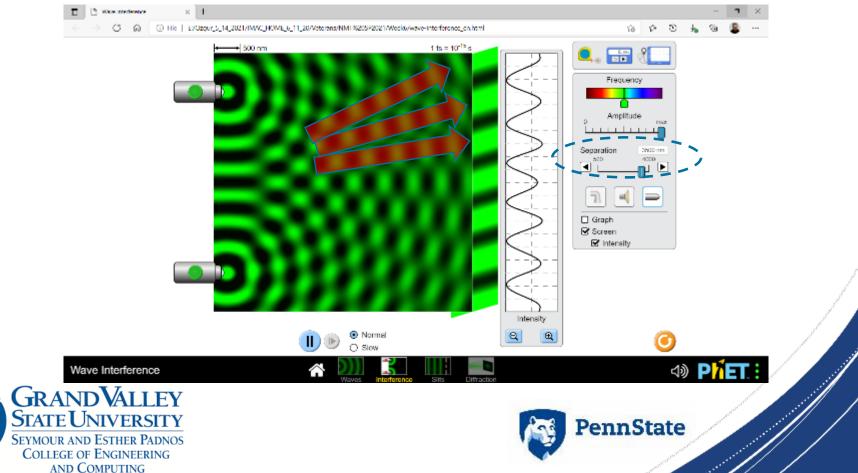






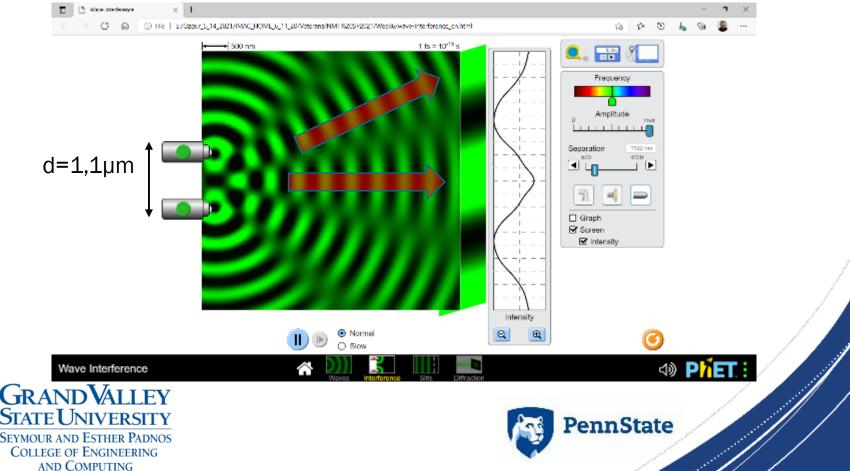
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- Examining Interference from two sources separated by a distance
  - Two sources separated by 3,5µm yields interference patterns that survive waves in the shown propagation directions (arrows).





- Examining Interference from two sources separated by a distance
  - $\bullet$  Two sources separated by 1,1  $\mu m$  yields the given intensity profile on the screen.





- Examining Interference from two sources separated by a distance
  - Students can deduce that d and arrow directions, which constitute the diffraction pattern are related to each other. As d increases, the arrows make a larger angle (θ) wrt the horizontal axis. Accordingly:

#### $d \propto \theta^{-1}$ (inversely proportional to each other)

• Similarly, the reflections from planes of arranged atoms scattering rays 1-3 in the figure below can also be thought of the same form. The collection angle ( $\theta$ ) is related to the separation between these planes.

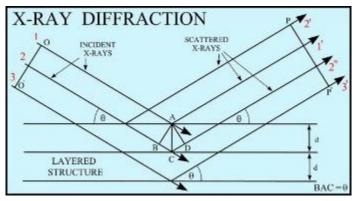




Image taken from Bragg Diffraction | PhysicsOpenLab PennState

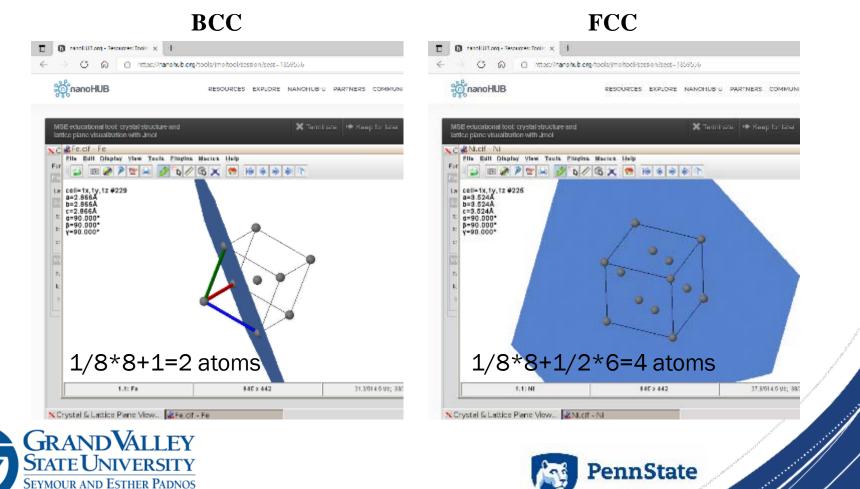


- Examining Interference from two sources separated by a distance
  - Nanohub offers <u>nanoHUB.org</u> <u>Resources: MSE educational tool:</u> <u>crystal structure and lattice plane visualization with Jmol</u> that helps easy visualization of the crystal planes and Bravais lattices.





• JMOL Exercise1: Counting number of atoms in BCC and FCC unit lattices.



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• JMOL Exercise2: Si crystal structure and shortest distance between atoms.

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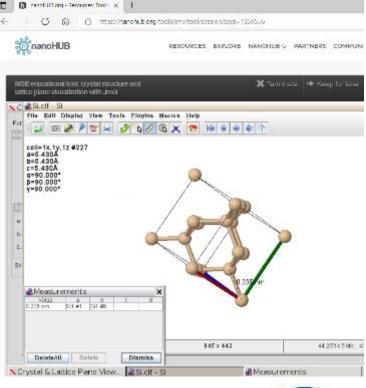
#### **Diamond lattice**

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• JMOL Exercise3: Si crystal structure and shortest distance between atoms.

#### Shortest Distance: 0.235nm







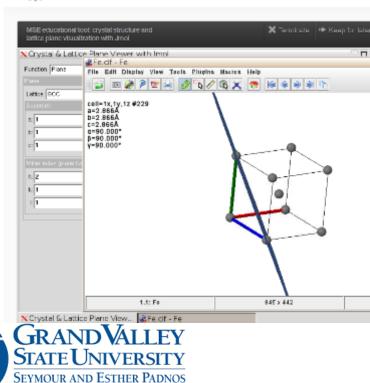


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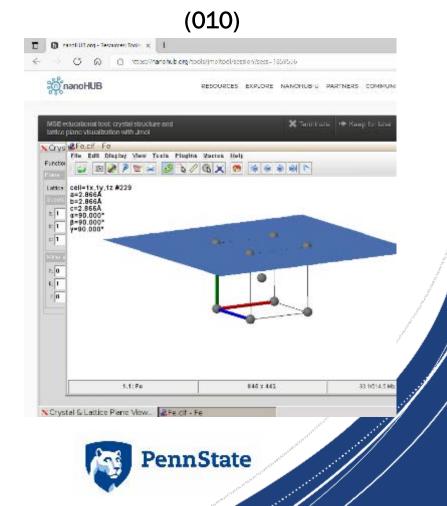
- JMOL Exercise4: Draw Miller planes for
  - (211) and (010) planes on BCC lattice.

## (211)nanolilli org - Besources: Tools: X O (a) https://nanohub.org/tools/jmoitool/session//ses RESOURCES EXPLORE NANOHUB-U PARTNERS COMMUNI

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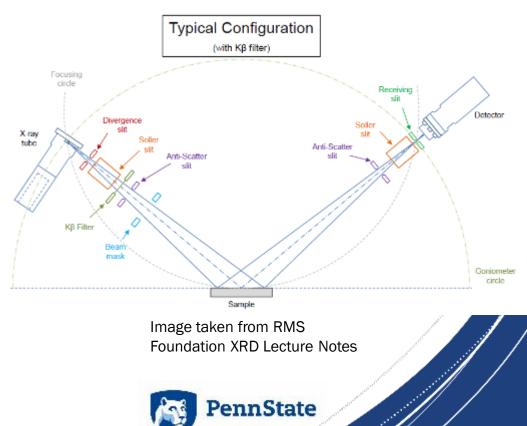
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- XRD simulations:
  - A typical configuration is shown below with the x-ray source on the left hand side and the detector on the right hand side. Optical elements are used to control the beam divergence.









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## **X-Ray Diffraction**













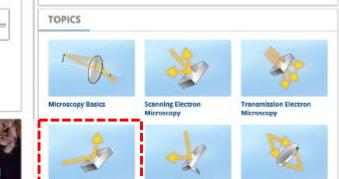






We sincerely hope you find the website an enjoyable environment where you can explore the microscopy space and leave ready to undertake your own exciting experiments.

Please choose a topic to learn more







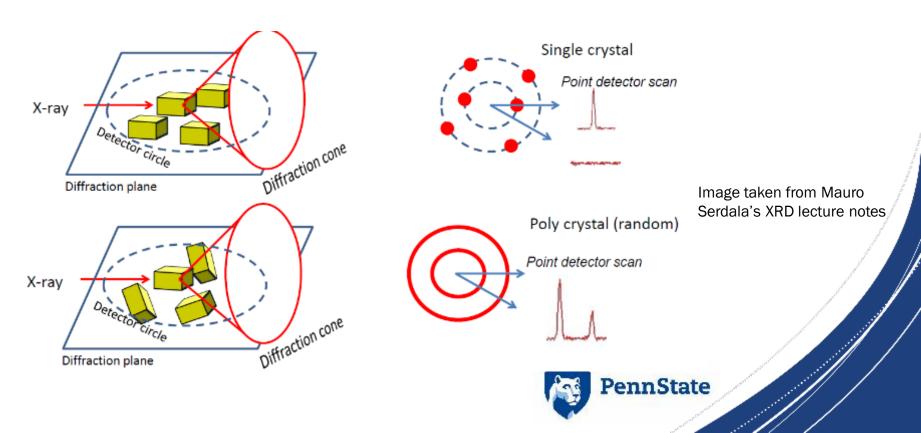






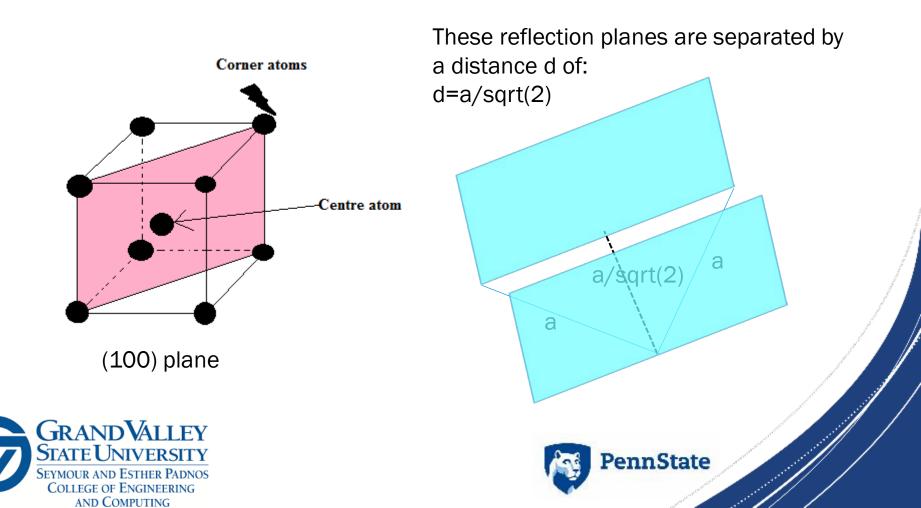


- XRD simulations:
  - Students get convinced that the planes of reflections will create different diffraction cones at the exit side. Crystalline structures will generate point inside the diffraction cone. <u>nanoHUB.org</u> -<u>Resources: MSE educational tool: X-ray diffraction (XRD) pattern</u>



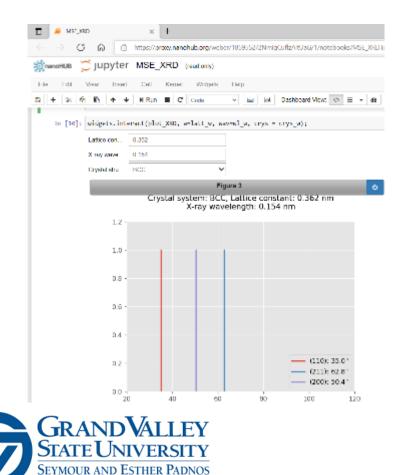


• XRD Exercise1: Collect peak locations for BCC and verify for (110) plane.





• XRD Exercise1: Collect peak locations for BCC and verify for (110) plane.



COLLEGE OF ENGINEERING AND COMPUTING  $2d\sin heta=n\lambda$ 

According to Bragg formula: n=1,  $\lambda$ =0.154nm (CuK $\alpha$ ), d=a/sqrt(2), a=0.362nm

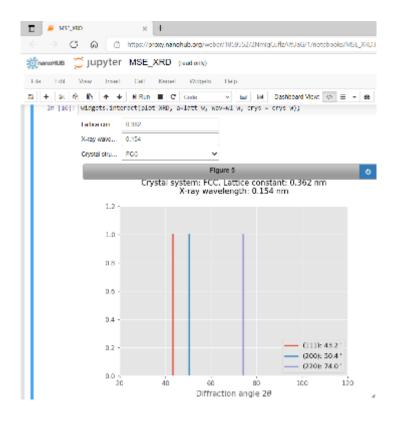
 $\theta = \sin^{-1}(0.154/(2*0.362/sqrt(2))) = 17.5 \text{ degrees}$ 



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• XRD Exercise2: Collect peak locations for FCC



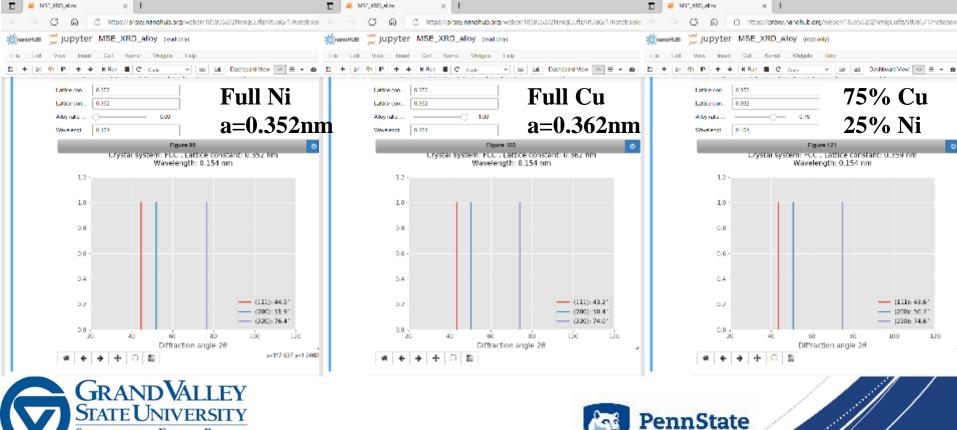






• XRD Exercise3: Finding alloy ratio of Ni-Cu alloy

• Instructor comes up with a hidden alloy ratio and asks students to figure it out by intelligent trials remembering that d and  $\theta$  are inversely proportional to each other. Let us say (220) plane  $2\theta=74.6$ .

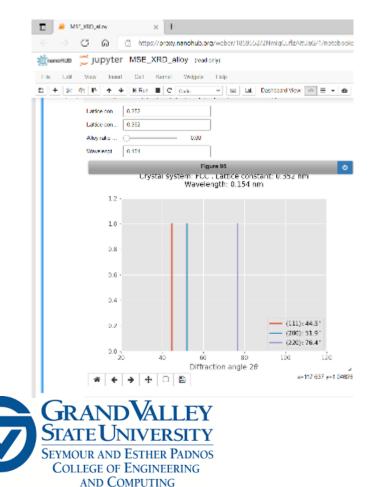


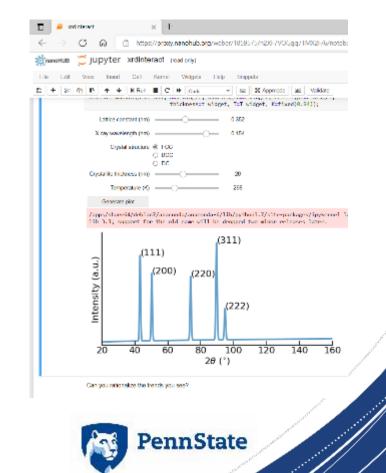
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#### <u>nanoHUB.org</u> - <u>Resources: XRD interactive trends plot</u>

• XRD interactive trends enables a simple calculation of the more realistic peaks with valid amplitudes.



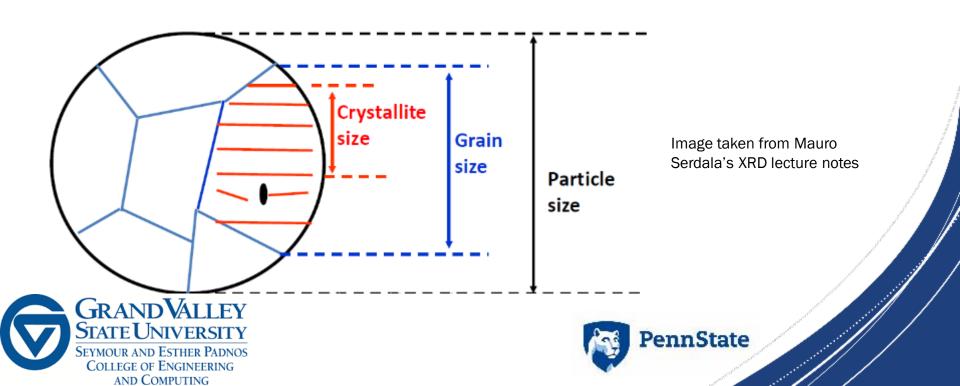


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• <u>nanoHUB.org</u> - <u>Resources: XRD interactive trends plot</u>

• XRD interactive trends enables a simple calculation of the more realistic peaks with valid amplitudes. Sherrer's equation is also integrated to take into account the grain sizes (thickness parameter)



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- XRD Exercise4: Comparing the grain size effects on FWHM
  - Grain size determines the peak broadening

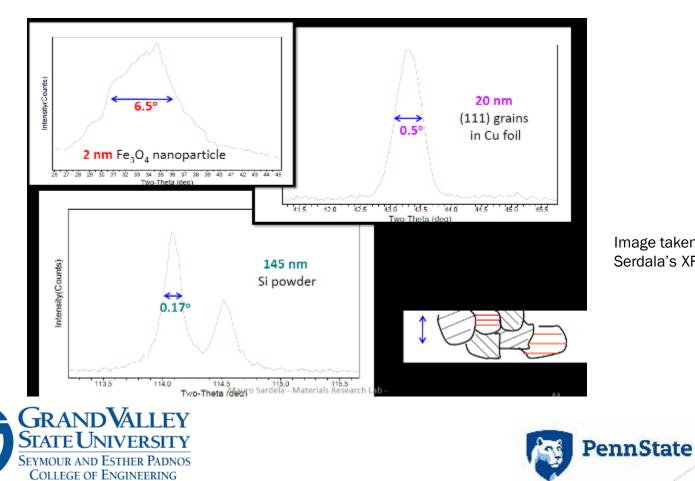
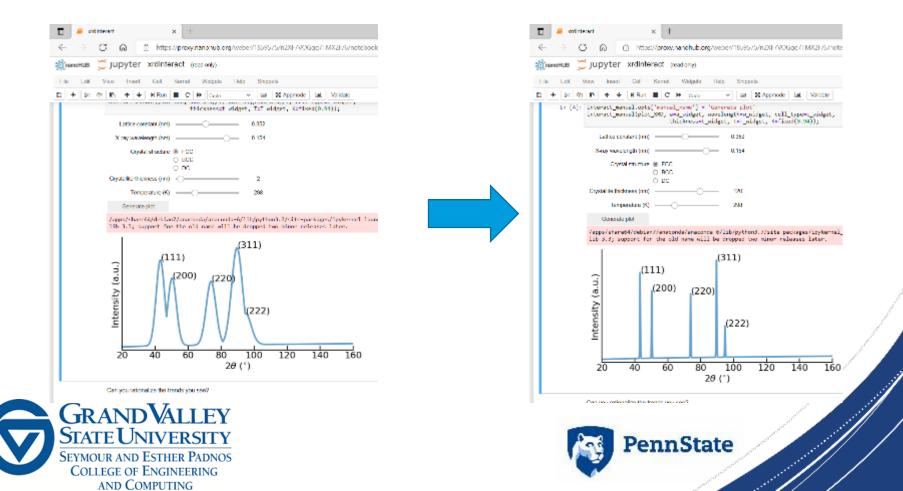


Image taken from Mauro Serdala's XRD lecture notes



- XRD Exercise4: Comparing the grain size effects on FWHM
  - Students observe the changes when grain size is entered as 2nm and 120nm





## • What is it and why is it important?

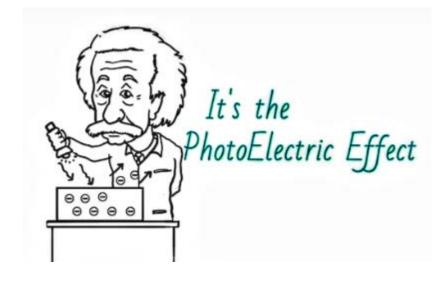
- Developed in 1960s as a surface analysis technique.
- Also known as Electron Spectroscopy for chemical analysis (ESCA).
- One of the most frequently used chemical analysis tool in order to determine
  - Elemental composition
  - Stoichiometry
  - Chemical state (e.g. oxidation state)
  - Electronic state of the elements

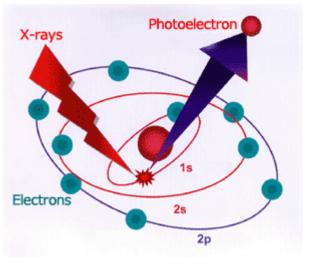






- What is it and why is it important?
  - Relies on the Photoelectric Effect: Shining a torchlight on any surface splashes away some surface electrons due to the acquired energy from the incident light.





Photoelectron Spectrometer (ESCA) | Introduction to JEOL Products | JEOL Ltd.







- Examining the Photoelectric Effect
  - Phet University of Colorado Boulder offers excellent simulations on Photoelectric Effect - Light | Quantum Mechanics | Photons - PhET Interactive Simulations (colorado.edu)
  - Explore the rest of the simulation APPs here: <u>Browse PhET Interactive</u> Simulations (colorado.edu)





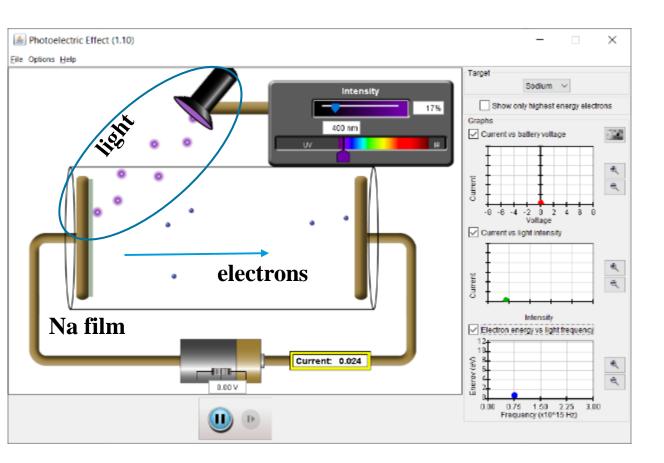




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#### • Examining the Photoelectric Effect



**Case1:** Illuminating Na (Sodium)

Light impinges on a thin Na film.

Electrons are extracted thanks to the illumination at 400nm wavelength with 17% intensity.

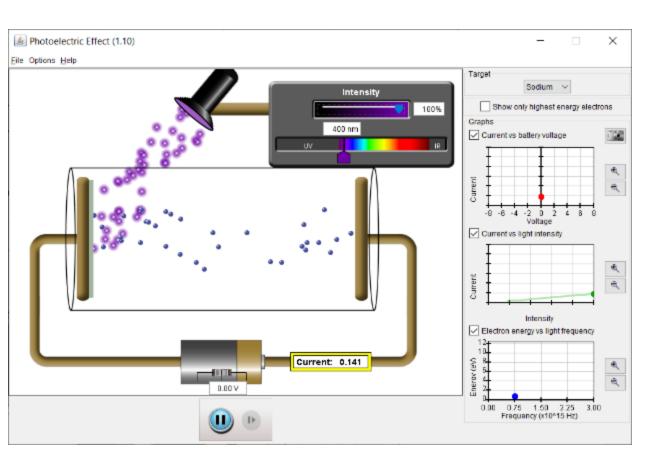
Displaced electrons go to the other electrode and yield current conduction of 0.024 Amperes.







#### • Examining the Photoelectric Effect



# **Case1:** Illuminating Na (Sodium)

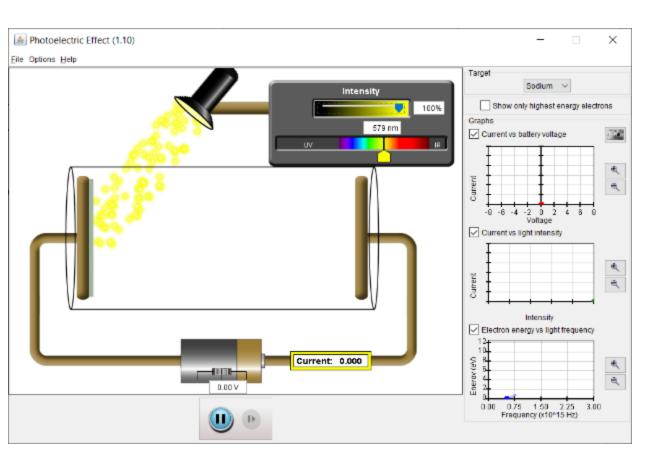
Increased intensity to 100% yields more electrons to be extracted. Thereby more current reading by the students. More photons impinging on the Na film extracts more electrons. More Intensity => More Light => More Electrons Extracted => More Current







#### • Examining the Photoelectric Effect



# **Case1:** Illuminating Na (Sodium)

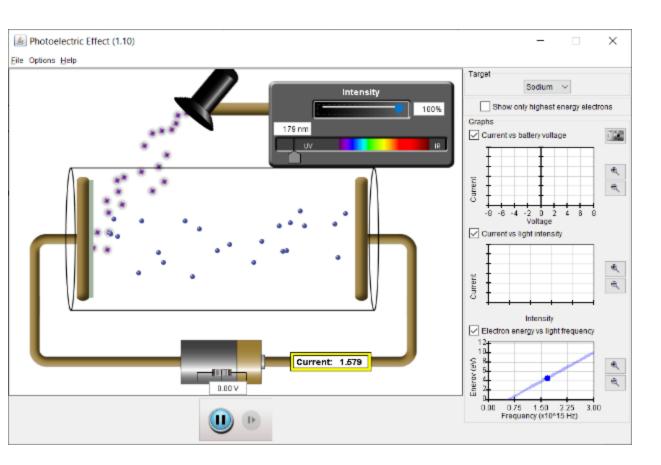
Increasing the wavelength of impinging light to 579nm. There is no electron extraction! Higher wavelength of light possesses lower energy, hence less or no electrons are extracted. Higher Wavelength => Less Energy of Light => Less or No Electrons Extracted => Less or No Current







#### • Examining the Photoelectric Effect



**Case1:** Illuminating Na (Sodium)

Opposite is also generally true (there are secondary effects outside of the scope). Lower wavelength => Higher Energy of Light => More Electrons Extracted => More Current

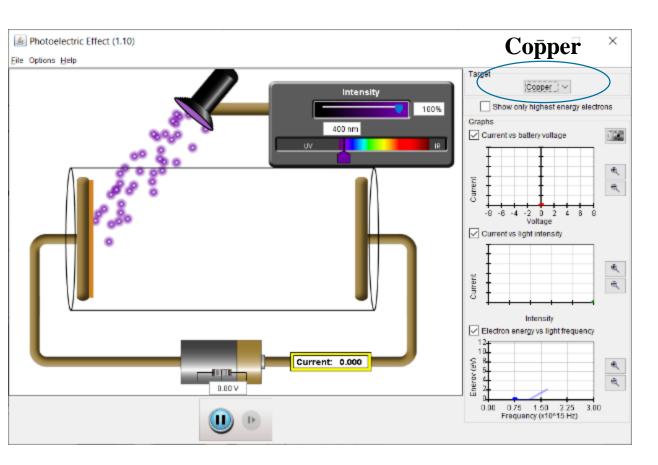




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• Examining the Photoelectric Effect



**Case2:** Illuminating Cu (Copper)

At wavelength of 400nm, Cu does not yield any current. No electrons extracted. Cu has higher atomic number (Z) and requires higher energy to extract the electrons. In other words, Cu has higher **binding energy**  $(E_{\rm B})!$ 

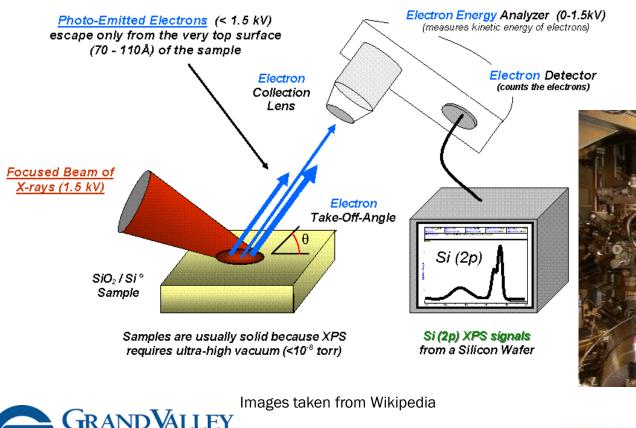




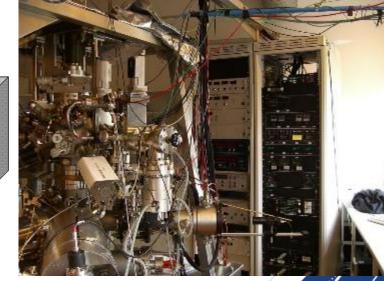


• XPS tool and exposure for the students

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Illuminating the surface with x-rays to extract core electrons to fulfill an elemental analysis. Might be challenging to give the exposure to the students with limited funds.

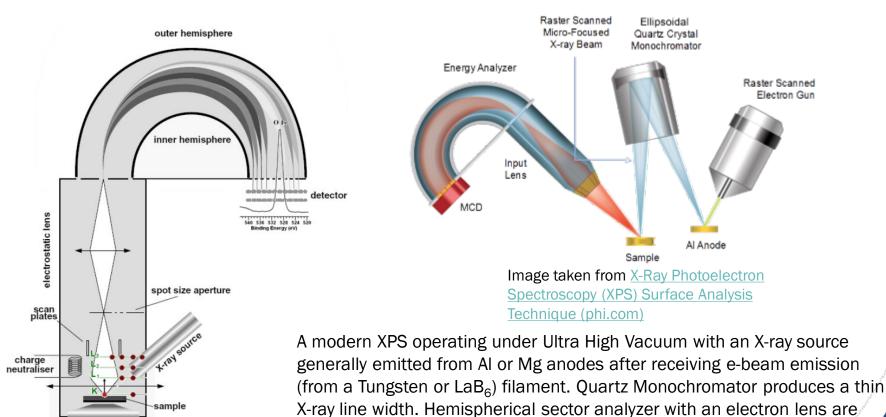








• XPS tool and exposure for the students



charging problems.

magnetic lens Image taken from Teignmouth Science and Technology Center



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employed on the receiver side. Charge neutralizer might be needed for



- SESSA: Simulation of the Electron Spectra for Surface Analysis
  - Go to <u>NIST Standard Reference Database 100 | NIST</u> to download the proper version to your computer.











#### • SESSA Exercise1: Cu survey result

• Set up a 10nm (thick) Cu layer on Si substrate from Sample tab.

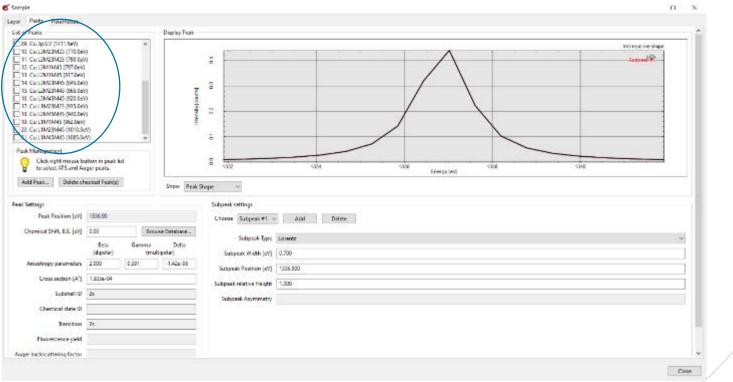
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#### • SESSA Exercise1: Cu survey result

• Go to Peaks tab, you will see that there are various Auger peaks, aside from the XPS peaks.









#### • SESSA Exercise1: Cu survey result

• Go to Spectrometer and set the lower and upper boundaries as 300eV and 1.2keV, respectively.

Source Geometry S	petrometer		
Choose Region #1	~ Add. Ceists	Rest	
Region Settings			
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#### • SESSA Exercise1: Cu survey result

• Go to Source and observe the incident X-ray source, which is an AIK $\alpha$  source with an incident energy (E<sub>i</sub>) of 1486eV.

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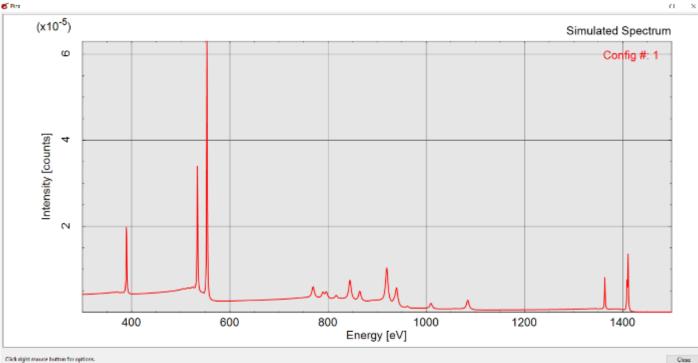
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#### • SESSA Exercise1: Cu survey result

 Go to Simulation tab and hit Start Simulation, you should obtain the following plot. Students can extract the peak values and corresponding energy values with the help of the mouse.



Click right mouse button for options.

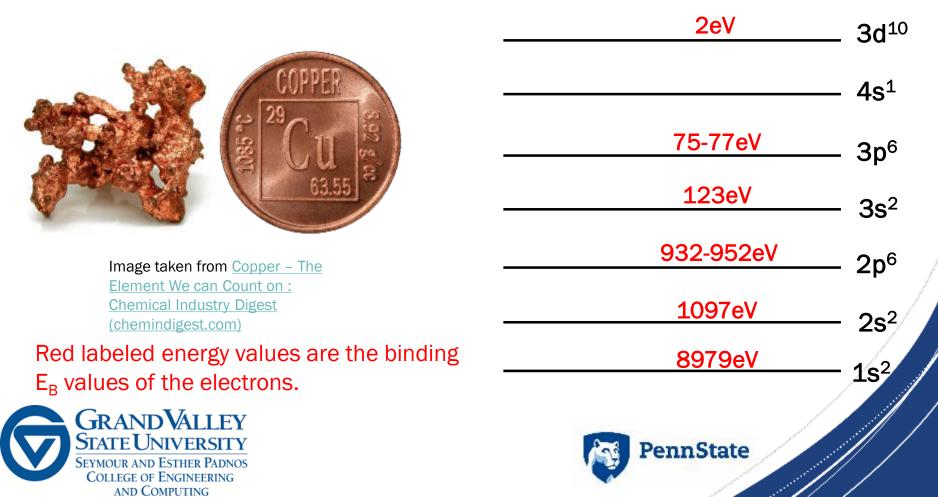






### • SESSA Exercise1: Cu survey result

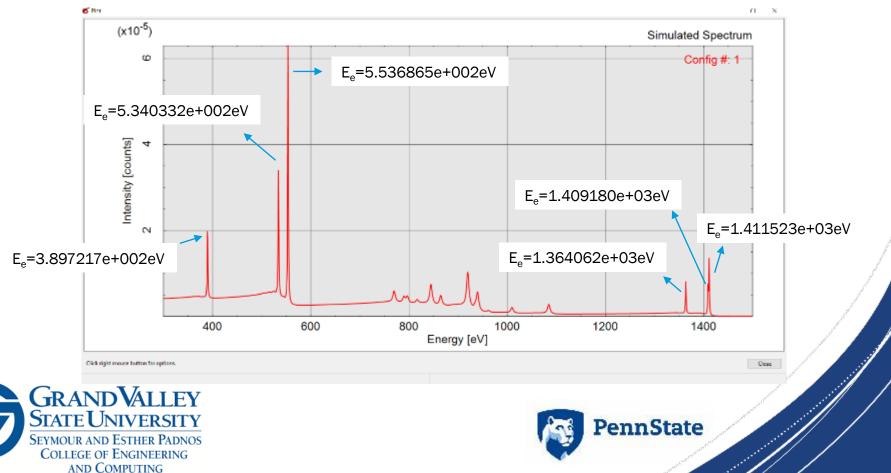
 Referring back to the Periodic Table, Cu can be arranged as: 1s<sup>2</sup>2s<sup>2</sup>2p<sup>6</sup>3s<sup>2</sup>3p<sup>6</sup>4s<sup>1</sup>3d<sup>10</sup>





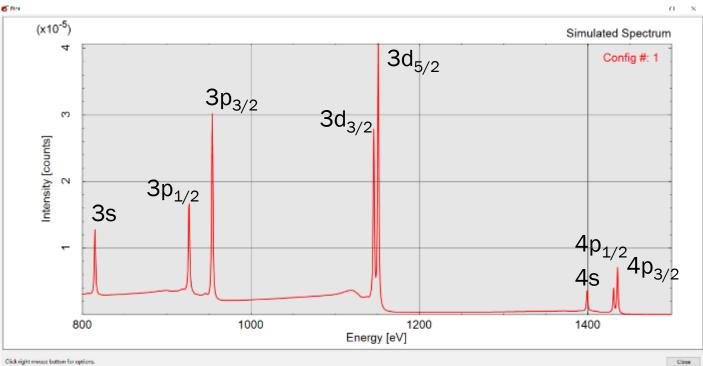
#### • SESSA Exercise1: Cu survey result

- Retrieved peaks (photoelectron Energy values)  $E_e$  and  $E_b$  values from the previous slide match? Energy should be conserved.
  - $1^{st}$  peak =>  $E_e = E_i = E_b = 1486 eV 1097 eV = 389 eV = 280 eV$  This is 2s photoelectron!
  - Other shown peaks can be checked and found that they are 2p, 3s and 3p photoelectrons!





- SESSA Exercise2: Pd survey result and spin-orbit splitting
  - Follow similar steps for 10nm Pd instead of Cu and collect the results. Should collect 8 peaks. The peaks are associated with orbits.



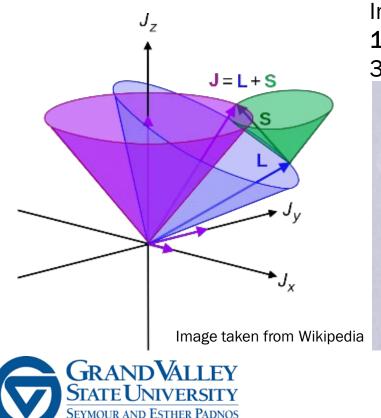
Click right mouse button for options.







- SESSA Exercise2: Pd survey result and spin-orbit splitting
  - Pd is a heavy atom with the dominant effect observed as L-S Coupling. More detailed reading can be found here: <u>Angular</u> <u>Momentum Coupling (gsu.edu)</u>



COLLEGE OF ENGINEERING AND COMPUTING Inner core electron configuration is 1s<sup>2</sup>2s<sup>2</sup>2p<sup>6</sup>3s<sup>2</sup>3p<sup>6</sup>3d<sup>10</sup>... will remove an electron from 3d

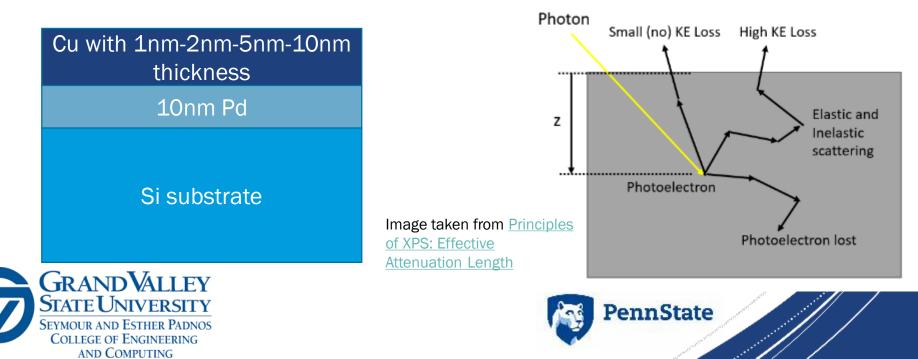


Total Angular Momentum: d orbit => L=2 S (spin)=1/2 |L-S| and |L+S| splitting will occur =>  $3d_{5/2}$  and  $3d_{3/2}$ p orbit => L=1 S=1/2 |L-S| and |L+S| splitting will occur =>  $3p_{1/2}$  and  $3p_{3/2}$ 



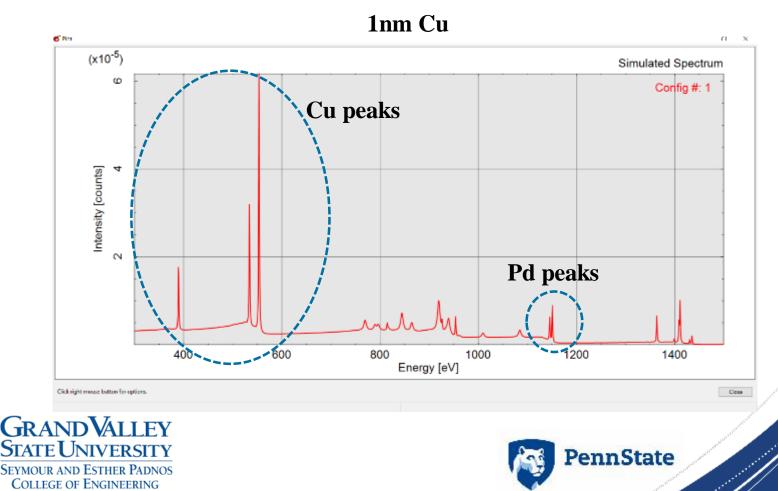


- SESSA Exercise3: Escape length, mean free path and surface sensing.
  - This exercise shows the surface sensing capability of XPS.
  - On top of the Pd layer stack a Cu layer with changing thicknesses from 1nm, 2nm, 5nm to 10nm. We will quickly lose the peaks from Pd layer as the top Cu layer is getting thicker. The photoelectrons will not be able to escape the surface.





• SESSA Exercise3: Escape length, mean free path and surface sensing.

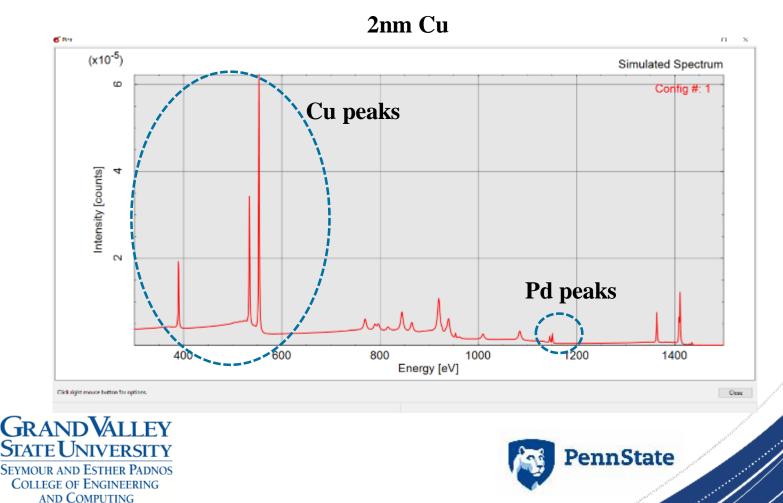


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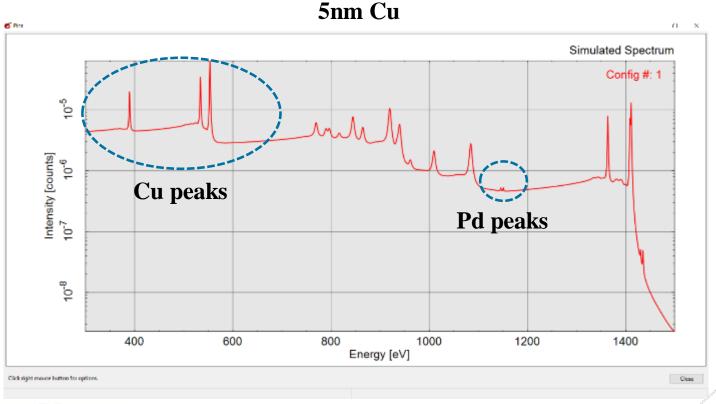


• SESSA Exercise3: Escape length, mean free path and surface sensing.





• SESSA Exercise3: Escape length, mean free path and surface sensing.

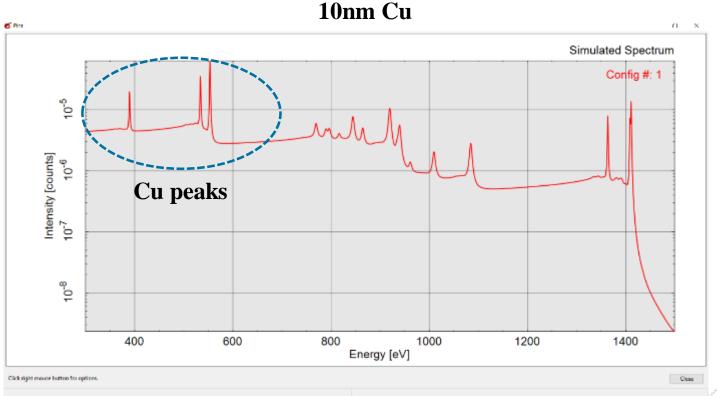








• SESSA Exercise3: Escape length, mean free path and surface sensing.



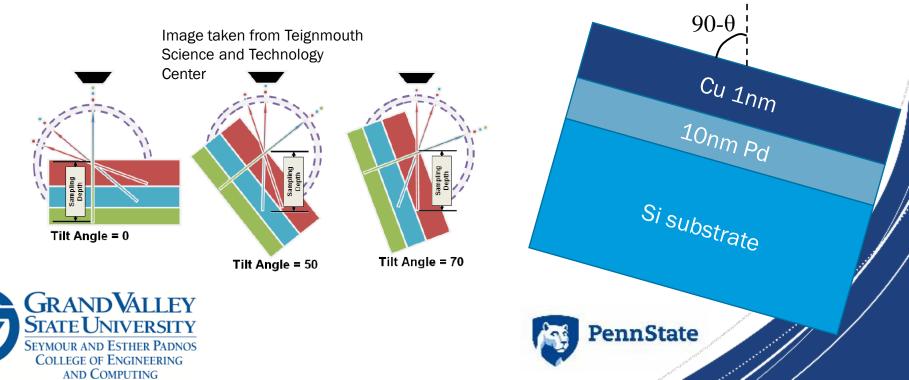






#### • SESSA Exercise4: Depth Profiling

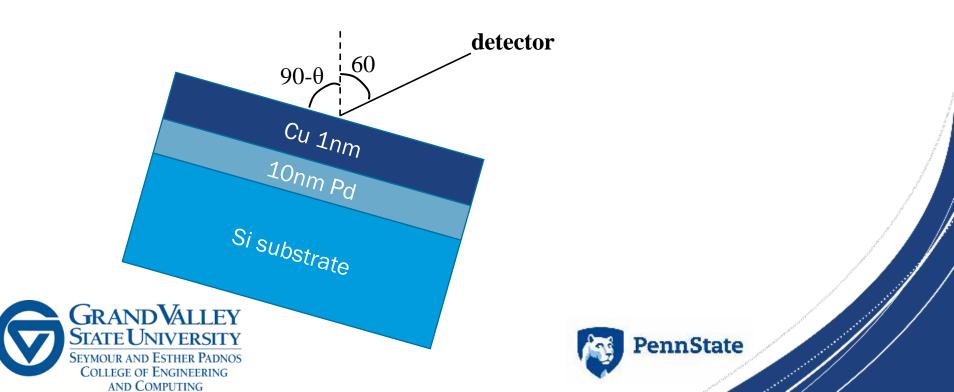
- Students can observe the sampling depth changes with the modifications done to the angle resolved XPS. The escape depth shrinks down with the tilted sample as schematically shown below.
- Change the tilt angle (Theta) from 0 to 30 to 60 degrees from Configurations tab.





### • SESSA Exercise4: Depth Profiling

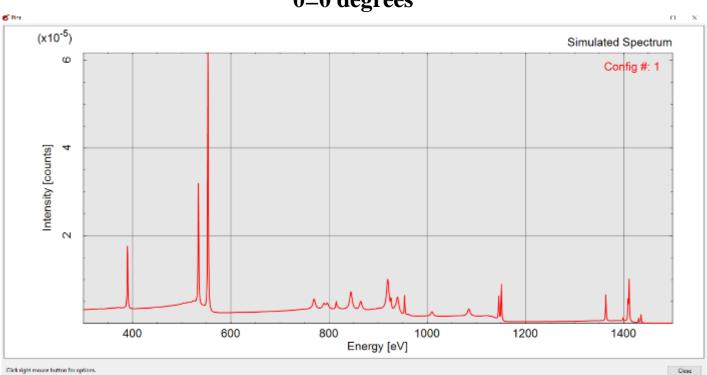
- Change the tilt angle (Theta) from 0 to 30 to 60 degrees from Configurations tab. Observe the changes in the signal intensity.
- Since the detector is already at a position with  $\theta$ =60 degrees, the highest signal intensity will be collected from the underlying Pd layer when the sample is also tilted the same amount.





#### • SESSA Exercise4: Depth Profiling

• Focusing on the Pd peaks only



 $\theta = 0$  degrees

Click right mouse button for options.

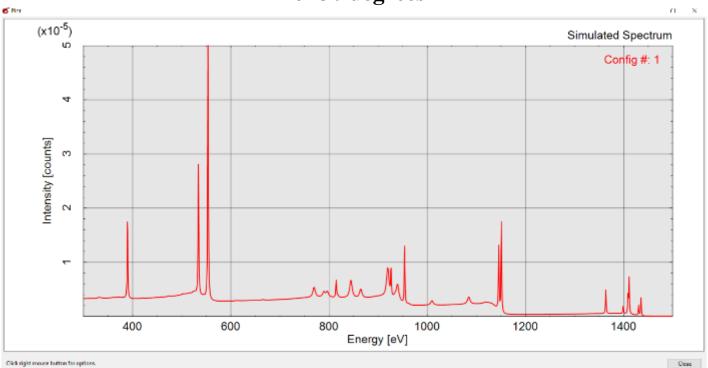






#### • SESSA Exercise4: Depth Profiling

• Focusing on the Pd peaks only



#### θ=30 degrees

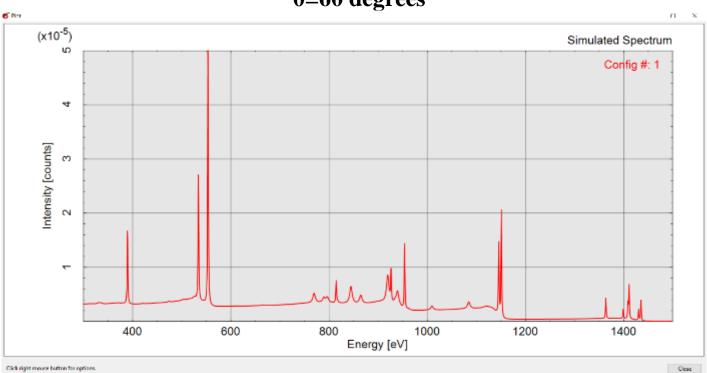






#### • SESSA Exercise4: Depth Profiling

• Focusing on the Pd peaks only



#### θ=60 degrees







#### • SESSA Exercise5: Chemical Shift

• Students can observe the effect of the electronegativity on the binding energy as shown below for the same C atom binding to F as the most electronegative partner with the highest binding energy.

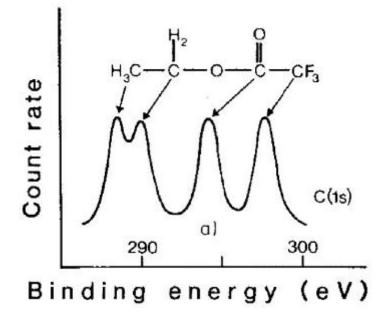


Image taken from Alessandro Kovtun's PhD thesis: 2D Graphene-based Materials. Interplay between Composition and Electrical Properties



- Go to Sources tab and change the X-ray source to MgKα which is at E<sub>i</sub>=1253.6eV
- We will observe the chemical shift as Si is oxidized.
- Go to Sample tab and change the material (single layer) to /Si[oxide]/O2/ for oxide





- SESSA Exercise5: Chemical Shift
  - Go to the Peaks tab and under Si 2p peaks click on the Chemical Shift and choose a Good estimation peak for the O bonded Si.

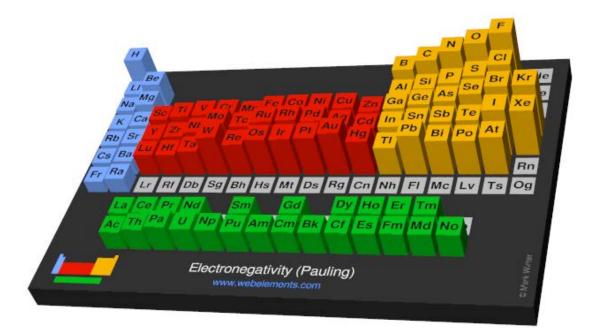


Image taken from <u>WebElements Periodic Table » Periodicity</u> <u>» Electronegativity (Pauling) » Periodic table gallery</u>







- SESSA Exercise5: Chemical Shift
  - Go to the Peaks tab and under Si 2p peaks click on the Chemical Shift and choose a Good estimation peak for the O bonded Si.

er Peaks Parameters					
ut of Pauka	Display Peak	Browse chemical shift dat	abase		×
20. Pd MTN23N45+2 (013.0eV)     21. Dd MTN45+2N45+2 (666.2eV)     22. St 22. St 22 (1320.5eV)     22. St 22 (1320.5eV)     21. St 4 (172.118.6eV)		Peak: Silicon - 2p1/2, oxid		on the mapsetive column in	ick spe radet.
24. Si 2p3/2 (1387.4cV)		Transition Chemicals	hift (e+ Chemical formula	MPAC name	^ ;
25. Se[oxide] 2s (1336.9eV)     26. Se[oxide] 2p1/2 (1385.8eV)		2p 3.100000	(-OCH2CH)(CH2O(CH2)35i(OCH3)3)-)#	poly(3-glycidoxypropyltrimethorysilane)	- 11
27, Si[owide] 2p3/2 (1387.4eV)		2p 4.100000	(-OCH2CH(CH2O(CH2)35(IOCH3)3)-)n	poly(3-glycidoxypropyltrimethoxysilane)	
28. O 1s (943.5eV)	2	2p 2.900000	(-Si(C6H5)2D-)n	poly(diphenyl allocane)	
29. 0 2s (1443,0eV)	and y	2p 4.700000	502	silicon dioxide (CasNo: 7031-86-9)	
30. O KL1L1 (477.0eV)	2	2p 4.00000	502	silicon dioxide (CerNo: 7631-86-9)	
31. O KL1L23 (496.5eV)		2p 4.600000	502	silicon dioxide (CasNo: 7631-86-9)	
32. O KL23L23 (516.0eV) 9		2p 3.70000	SIGE	silicon dioxide (CasNo: 7631-86-9)	
Peak Management		2p 4.400000	502	silicon dioxide (CasNo: 7631-86-9)	
Click right mouse button in peak list		i		Later a start to the total to	·
to select XPS and Auger peaks.					
Add Peak	1	Full information		Reference	1.00
Anisotropy parameters 2,000 0.391 -1.42e-06		Chemical Juffe 4,70000 eV Children Colle, Jp. 932-82, 75,113 Charge reference: Au Line Digit 2p Remark: Quality: Good Chemical Info 3: 502 Chemical Info 3: silicon disside (CasNer 7631-86-9)		Journal: Apel, Surf. Sci. 26, 129 Volume: Year: 1986 Page Ratubelity: Remarks	
Cross section (A <sup>2</sup> ) 1.303e-04					1000
Subshell ID 2				Cancel Select chemical st	sft
		· · · · ·			34
Chemical state ID oxide	cal state ID ou like				
Transition 2x					
Fluorescence yield	1				
luger backscattering factor					

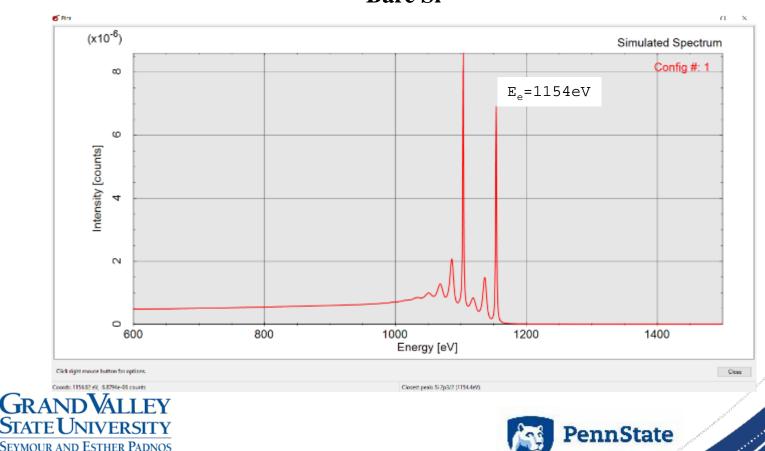






#### • SESSA Exercise5: Chemical Shift

• Notice that 2p states are very close to each other for Si and yield a seemingly single peak.



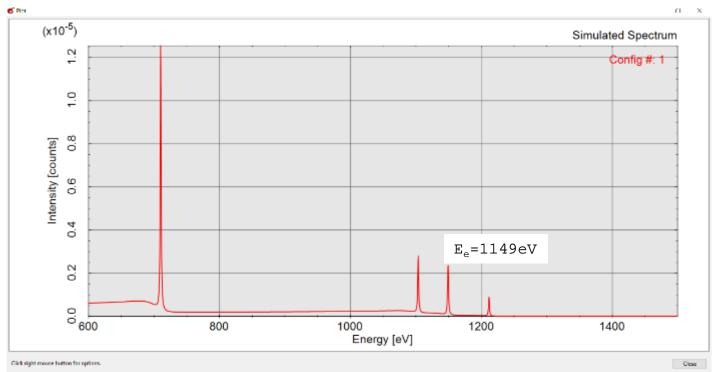
#### Bare Si

COLLEGE OF ENGINEERING AND COMPUTING



### • SESSA Exercise5: Chemical Shift

• Notice that 2p states are shifted by around 5eV to lower values, meaning that  $E_B$  is increased as a result of the O bond to the Si.



#### **Oxidized Si**



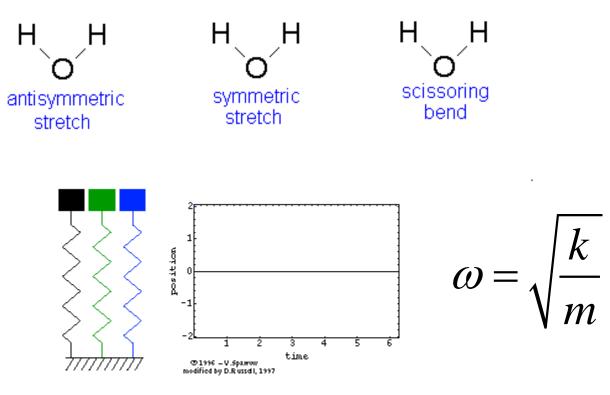
SEYMOUR AND ESTHER PADN COLLEGE OF ENGINEERING AND COMPUTING Closest peaks Si 2p3/2 (1149.7eV)





59

## **FTIR**



The stronger the spring the faster the vibration and the higher the frequency

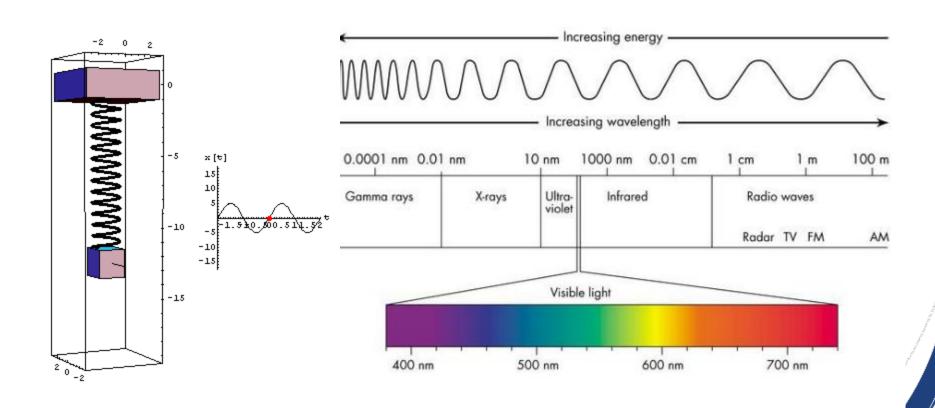
Masses and springs





NACK

**FTIR** 

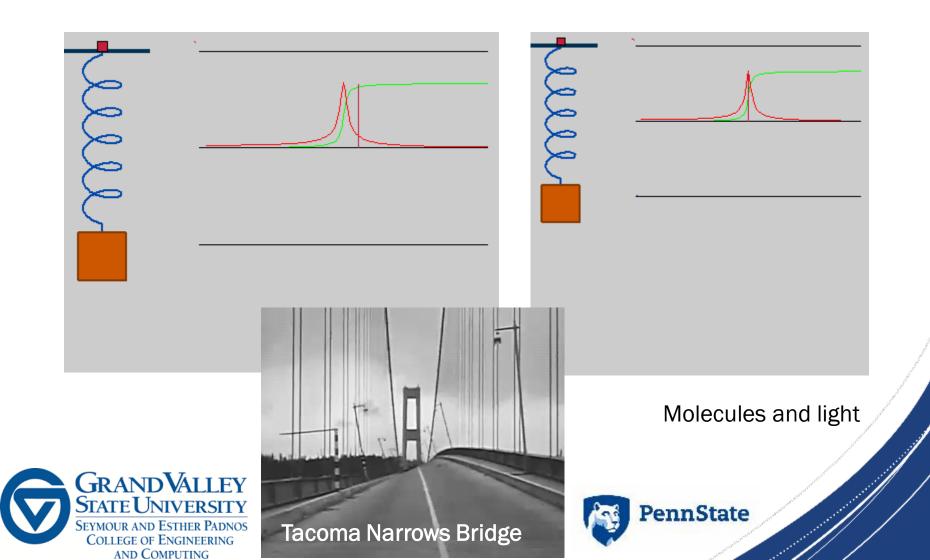




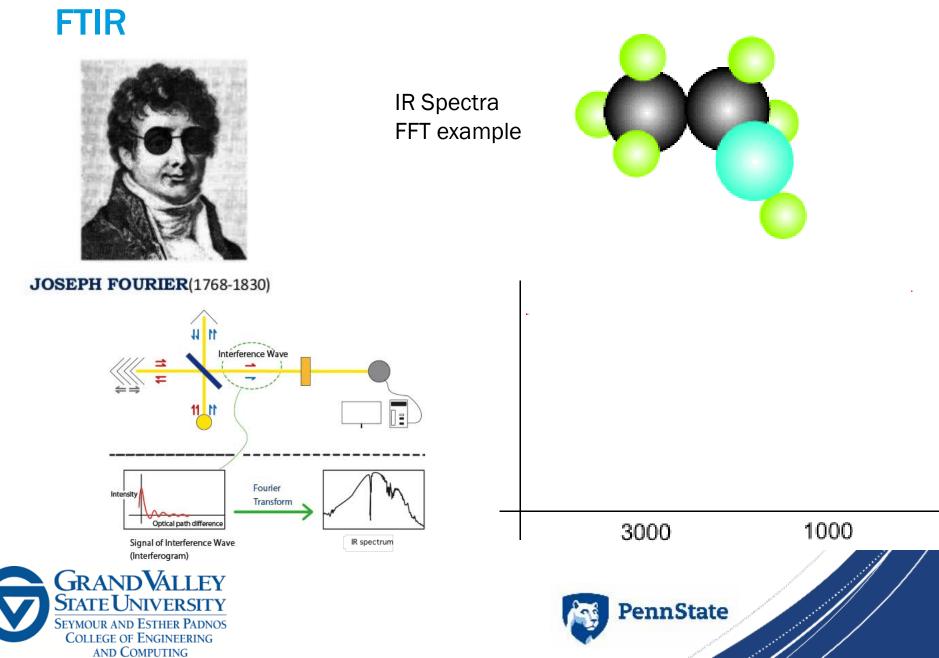


NACK

**FTIR** 

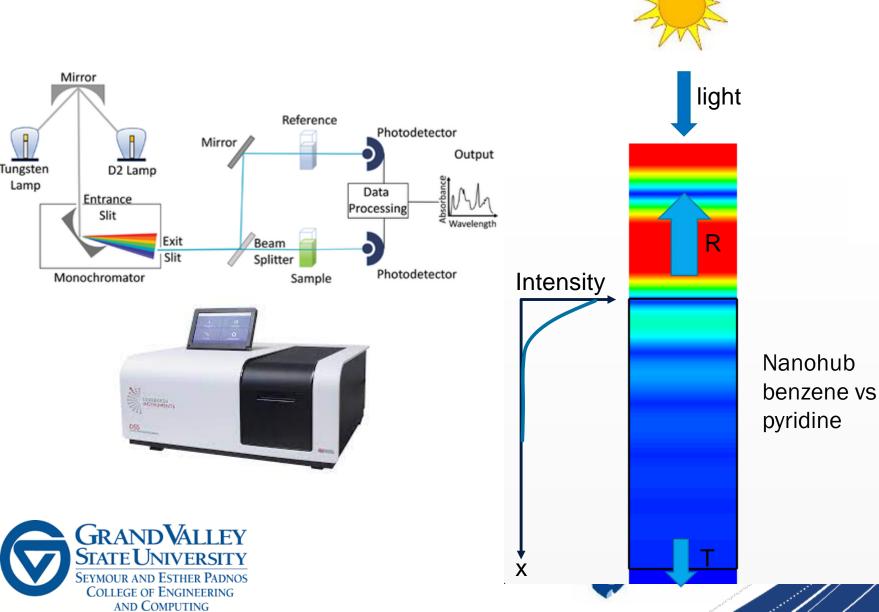






Uvvis

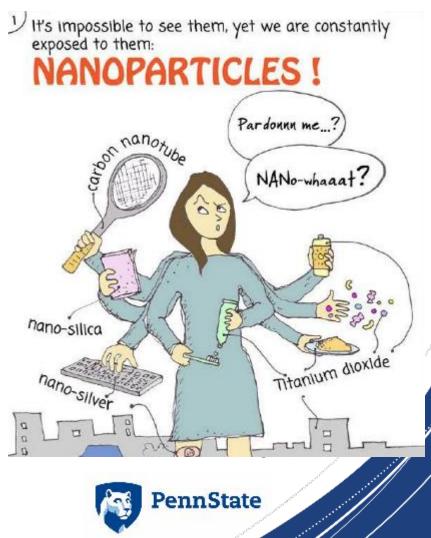






### Uvvis



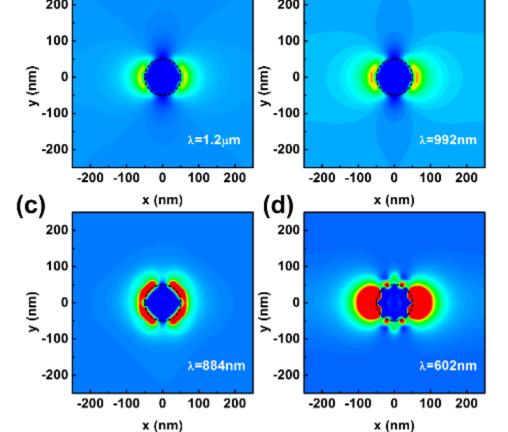








# Uvvis (a) (b) 200 200





Nanoantennas! => Nanohub Nanosphere Lab







## Summary

- XRD => Send X-ray and look at the diffraction patterns
  - Crystal structure
  - Crystal size
  - Internal stress
  - Composition
- XPS => Send X-ray and look at the extracted electrons (photoelectrons)
  - Elemental composition
  - Stoichiometry
  - Chemical state (e.g. oxidation state)
  - Electronic state of the elements
- FTIR => Send IR light and vibrate the chem. bonds and inspect the absorption (loss) of light. Uses Fourier Transform on Interference Patterns.
  - Identify bonds
  - Identify compounds, organics and polymers
  - Identify contamination, oxidation
- UV vis => Send UV and visible spectrum light, look at transmission and absorption. Identify how much a substance absorbs light.







Building College-University Partnerships for Nanotechnology Workforce Development

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